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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
HASEGAWA, Eiji

New York, New York
Date: August 1, 2005

Serial No.: 10/768,611 Group Art Unit: 2812

Date Filed: January 29, 2004

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY LETTER

Sir:

We filed the above application with the U. S. Patent and Trademark Office on January 29, 2004.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,



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